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Notice of Allowability	Application No.	Applicant(s)	
	10/798,013	SASAKI, HIROSHI	
	Examiner	Art Unit	
	Que T. Le	2878	<u> </u>
The MAILING DATE of this communication at All claims being allowable, PROSECUTION ON THE MERITS herewith (or previously mailed), a Notice of Allowance (PTOLNOTICE OF ALLOWABILITY IS NOT A GRANT OF PATENT of the Office or upon petition by the applicant. See 37 CFR 1.	IS (OR REMAINS) CLOSED in 85) or other appropriate common RIGHTS. This application is s	n this application. If not include unication will be mailed in due	led course. THIS
1. This communication is responsive to			
2. X The allowed claim(s) is/are <u>1-38</u> .			
3. Acknowledgment is made of a claim for foreign priority a) All b) Some* c) None of the: 1. Certified copies of the priority documents h 2. Certified copies of the priority documents h 3. Copies of the certified copies of the priority	ave been received. ave been received in Application documents have been received. TE" of this communication to file NMENT of this application. Abmitted. Note the attached EXA gives reason(s) why the oath of must be submitted. Derson's Patent Drawing Review	on No d in this national stage applicate a reply complying with the research AMINER'S AMENDMENT or It related to the declaration is deficient.	equirements
(b) including changes required by the attached Examir Paper No./Mail Date Identifying indicia such as the application number (see 37 CF)	ner's Amendment / Comment on	he drawings in the front (not th	e back) of
each sheet. Replacement sheet(s) should be labeled as such 6. DEPOSIT OF and/or INFORMATION about the de attached Examiner's comment regarding REQUIREME	eposit of BIOLOGICAL MATI	ERIAL must be submitted.	Note the
Attachment(s) 1. ☑ Notice of References Cited (PTO-892) 2. ☐ Notice of Draftperson's Patent Drawing Review (PTO-94) 3. ☑ Information Disclosure Statements (PTO-1449 or PTO/S Paper No./Mail Date 4. ☐ Examiner's Comment Regarding Requirement for Depos of Biological Material	6. ☐ Interview S Paper No. B/08), 7. ☑ Examiner's	. طِ	owance
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An examiner's amendment to the record appears below. Should the changes and/or additions be unacceptable to applicant, an amendment may be filed as provided by 37 CFR 1.312. To ensure consideration of such an amendment, it MUST be submitted no later than the payment of the issue fee.

The <u>title of the invention</u> has been changed to: "Scanning laser microscope having a spectrum image positional correction".

The following is an examiner's statement of reasons for allowance: The prior art fails to teach a scanning laser microscope, among other features, comprising: a laser source; a dispersive element disperses light emitted from a sample and makes spectrum; an image formation element forming an image of spectrum made by the dispersive element; a photodetector for detecting light in each wavelength band being arranged in the spectral direction; at least one optical element selectively arranged between the sample and the dispersive element; and a correction portion for correcting a positional relationship of a position of the spectrum image which is displaced due to a change caused by switching the optical element. The prior art also fails to teach a scanning microscope, among other features, comprising: a laser source; a plurality of spectral beam splitters dividing emitted light from a sample into respective light in accordance with a plurality of wavelength band when irradiating the sample with the laser beam; a plurality of dispersive elements disperses to spectrums the respective light according to the wavelength band divided by the splitters; a plurality of image

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formation elements each forms an image of the spectrums; a plurality of wavelength band extraction portions extract respective light in at least one wavelength band from the respective spectrums; a plurality of photodetectors; and a correction portion having stored correction quantities corresponding to each of the displacements of the spectrum image position relative to each of the beam splitters to control the rotation of the dispersive elements in accordance with the correction quantity relative to the spectral beam splitter when switched to this spectral beam splitter, and to correct the spectrum image positions relative to the wavelength band extraction portions.

Any comments considered necessary by applicant must be submitted no later than the payment of the issue fee and, to avoid processing delays, should preferably accompany the issue fee. Such submissions should be clearly labeled "Comments on Statement of Reasons for Allowance."

The prior art made of record and not relied upon is considered pertinent to applicant's disclosure.

I) Yokoi 6,396,053 discloses a scanning microscope system having an array of light deflecting microelements.

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Que T. Le whose telephone number is (571) 272-2438.

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If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, David P. Porta, can be reached on (571) 272-2444. The fax phone number for the organization where this application or proceeding is assigned is (703) 872-9306.

Any inquiry of a general nature or relating to the status of this application or proceeding should be directed to the receptionist whose telephone number is (703) 308-0956.

Que T. Le

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Primary Examiner